

Form PTO-1449

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062020-1540Serial No.
10/699,330Applicant
Kohl, et al.Filing Date
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Not yet assigned

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

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EXAMINER'S SIGNATURE: *J. Microelectromechanical Sys., vol. 10, No. 3, pp. 400-8, September 2001.* DATE CONSIDERED:

*Hoa Van Le**16 October 2007*

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<i>Le</i>	O	S. C. Narang, S. T. Attarwala, Chemical Amplification in t-Diol Polycarbonate Resists, <i>Polym. Prepr. (Am. Chem. Soc. Div. Polym. Chem.)</i> , vol. 26(2), p. 323, 1985.		
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